

IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

#2d
1-19.01
11040 U.S. PTO
09/917842



Applicant(s): **Chin, et al.**

Case: **5017/ISM/CORE MCVD/SB**

Serial No.: **Not yet assigned**

Filed: **Herewith**

Group Art Unit: **Not yet assigned**

Title: **ATOMIC LAYER DEPOSITION APPARATUS**

THE COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, DC 20231

S I R:

Disclosure Statement Under 37 C.F.R. 1.56 and 1.98

Pursuant to 37 C.F.R. 1.56, the documents (copies enclosed) listed on form PTO-1449, submitted herewith, are disclosed. Under Rule 37 C.F.R. 1.98(a), the Applicants submit that no specific comments are necessary for any of the cited English language publications having an enclosed English language translation or abstract.

Respectfully submitted,

July 5, 2001
Date

By:

Patricia A. Verlangieri
Patricia A. Verlangieri, Attorney
Reg. No. 42,201
(732) 530-9404

Thomason, Moser & Patterson, LLP
595 Shrewsbury Avenue
Suite 100
Shrewsbury, NJ 07702